

Docket No.: M1071.1392

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Yutaka Takeshima, et al.

*412*  
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Application No.: 09/916,804

Group Art Unit: 1762

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Examiner: M. Barr

For: **METHOD OF PRODUCING COMPLEX  
OXIDE THIN-FILM AND  
PRODUCTION APPARATUS**

Assistant Comissioner for Patents  
Washington, D.C. 20231

*Handy*  
*2/26/03*

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Dear Sir:

I am the attorney of record in the above-identified application.

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Respectfully submitted,

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Dated: February 22, 2003